

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
KOHEI KAWAMURA, ET AL. : EXAMINER: KEVIN A. PARENDO  
SERIAL NO: 10/567,733 :  
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823  
FOR: FLUORINE DOPED CARBON :  
FILMS PRODUCED BY  
MODIFICATION BY RADICALS

PETITION TO CORRECT INVENTIVE ENTITY UNDER 37 C.F.R. § 1.48(a)

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

This Amendment and Petition under 37 C.F.R. § 1.48(a) is to delete the names of the following persons originally named as inventors in the above-identified patent application in error and without deceptive intent. The names of the inventors to be deleted are:

Kohei KAWAMURA; and  
Yasuo KOBAYASHI.

The correct inventors of the present application are:

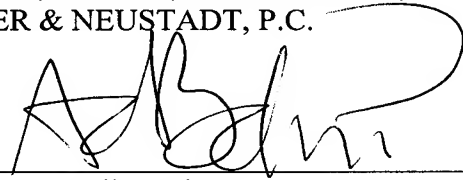
Kenichi NISHIZAWA;  
Yasuhiro TERAII; and  
Akira ASANO.

Applicants submit herewith a processing fee set forth in § 1.17(i) and Substitute Declaration and Supplemental Application Data Sheet under separate cover for the purpose of correcting the above inventorship.

Accordingly, Applicants request the correction to the inventive entity be entered and the Petition granted.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

A handwritten signature in black ink, appearing to read 'S. Weihrouch', written over a horizontal line.

Steven P. Weihrouch  
Attorney of Record  
Registration No. 32,829

Customer Number  
**22850**

Tel: (703) 413-3000  
Fax: (703) 413 -2220  
(OSMMN 08/07)

SPW/AHB/yst

Adnan H. Bohri  
Registration No. 62,648

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FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823  
FOR: METHOD FOR FORMING FILM, :  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR DEVICE AND  
SUBSTRATE TREATMENT  
SYSTEM

STATEMENT OF INVENTOR TO BE DELETED

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

I, Kohei KAWAMURA, a named inventor for U.S. Patent Application Serial No.  
10/567,733, state the following:

1. I should be deleted from inventors for U.S. Patent Application Serial No.  
10/567,733;
2. My addition to the original declaration was an error; and
3. The error arose without any deceptive intention on my part.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009

Kohei Kawamura  
Kohei KAWAMURA

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SUBSTRATE TREATMENT  
SYSTEM

STATEMENT OF INVENTOR TO BE DELETED

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

I, Yasuo KOBAYASHI, a named inventor for U.S. Patent Application Serial No.  
10/567,733, state the following:

1. I should be deleted from inventors for U.S. Patent Application Serial No.  
10/567,733;
2. My addition to the original declaration was an error; and
3. The error arose without any deceptive intention on my part.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009

  
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Yasuo KOBAYASHI

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SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR DEVICE AND  
SUBSTRATE TREATMENT  
SYSTEM

STATEMENT OF ASSIGNEE

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

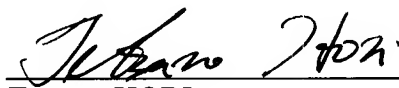
I, TOKYO ELECTRON LIMITED, the assignee of the entire interest of U.S. Patent  
Application Serial No. 10/567,733, state the following:

1. The inventors of U.S. Patent Application Serial No. 10/567,733 are Kenichi  
NISHIZAWA, Yasuhiro TERAII, and Akira ASANO.
2. The originally named inventors, Kohei KAWAMURA and Yasuo KOBAYASHI  
should be deleted as inventors in U.S. Patent Application Serial No. 10/567,733.
3. The error arose without any deceptive intention on the part of the assignee.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009



Tetsuro HORI

Vice President & General Manager, Legal/Intellectual Property  
TOKYO ELECTRON LIMITED